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				Application Number	10/774,406	
i	NFORMATION DIS	SCLOS	URE	Filing Date	2/10/2004	
	STATEMENT BY A	APPLIC.	ANT	First Named Inventor	Y. TANABE, et al.	
				Art Unit	2813	
	files se many chaste se	-	1	Examiner Name	Thanhha S. PHAM	
Sheet	Sheet 1 of 2		Attorney Docket Number	501.37465CC8		

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Examiner Initials'	Cite No.1	Document Number Number-Kind Code ³ (if known)		tion Date D-YYYY		ame of Patentee or cant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
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		•	P.	Application Number	10/774,408	
INFO	RMATIO	N DISCL	OSURE	Filing Date	2/10/2004	
STA	TEMENT	BY APP	LICANT	First Named Inventor	Y. TANABE, et al.	
				Group Art Unit	2813	
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Examiner	Cite	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the	T ²
nitials*	Cite No.	item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	Ľ
~		KOOI E ET AL: "Formation of silicon nitride at a SI-SI02 interface during local oxidation of silicon and during heat-treatment of oxidized silicon in NH3 gas" JOURNAL OF THE ELECTROCHEMICAL SOCIETY USA, vo 123, no. 7, July 1976 (1976-07), pages 1117-1120.	
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Signature	Considered	4 4707

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